



PATENT
5480-00201

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Kim, Dong-Soo

Serial No. 09/287,602

Filed: April 7, 1999

For: GAS SCRUBBER FOR TREATING
GAS GENERATED FROM A
SEMICONDUCTOR
MANUFACTURING PROCESS

Group Art Unit: 1764
Examiner: Tran, H.

Atty. Dkt. No. 5480-00201

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I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: **Box Non-Fee Amendment** Commissioner for Patents, Washington, D.C. 20231 on the date indicated below:

August 19, 2003
Date

Kevin Daffer

AMENDMENT; RESPONSE TO OFFICE ACTION MAILED MAY 19, 2003

Box: Non-Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Dear Sir/Madam:

This paper is submitted in response to the Office Action mailed May 19, 2003 to further highlight reasons why the application is in condition for allowance. Please amend the case as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Amendments to the Drawings begin on page 8 of this paper.

Remarks/Arguments begin on page 9 of this paper.